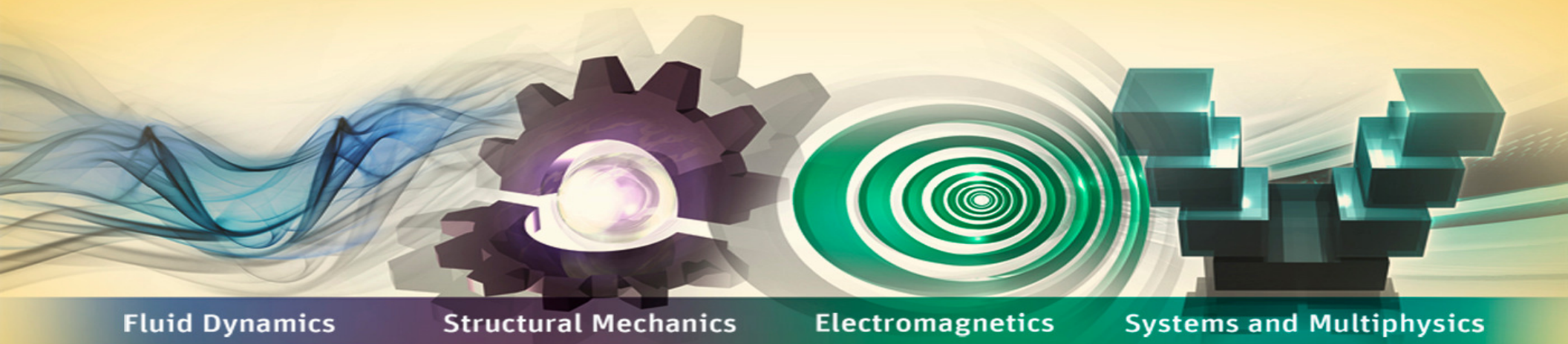


ANSYS Piezo-Electric and MEMS Solutions



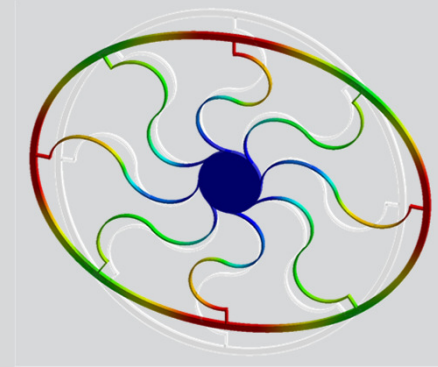
By: MingYao.Ding@Ansys.com

Agenda

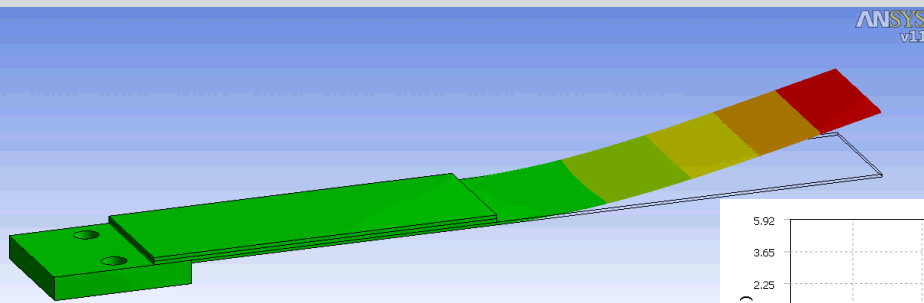
- **Background**
 - MEMS devices
 - ANSYS Piezoelectric and MEMS Capabilities
- **ANSYS MEMS workflows**
 - Geometry import
 - ANSYS Piezoelectric and MEMS ACT extension
- **Examples**
 - Piezoresistive pressure sensors
 - Surface acoustic wave resonators
 - Gyroscope

MEMS devices

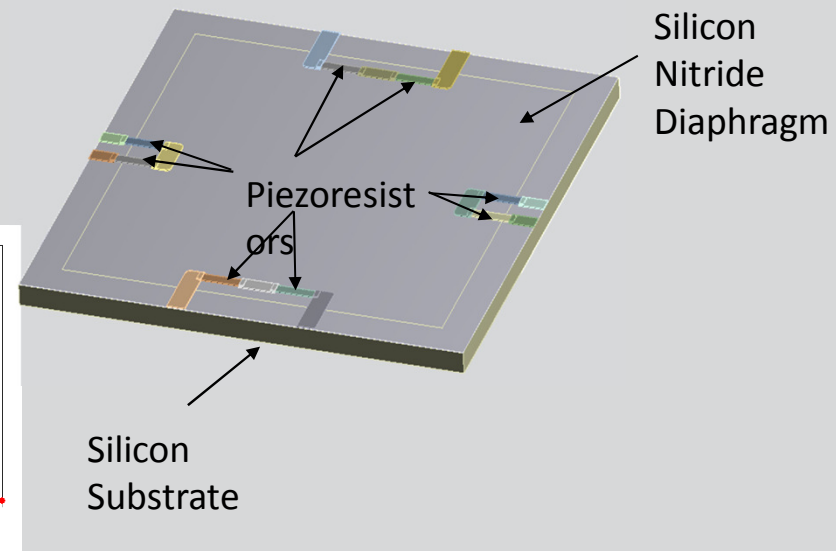
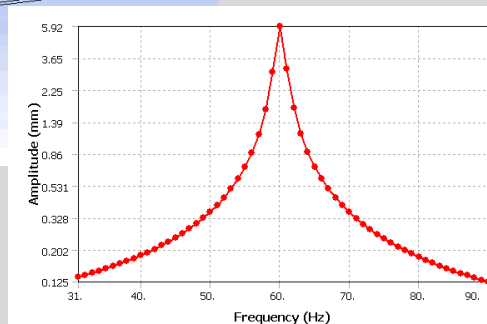
- **MicroElectromechanical Systems (MEMS)** - also is called micromachines and microsystems in Asia and Europe.
- **Made with semiconductor construction techniques, these devices have tiny parts measured in microns (millionths of a meter) and are frequently combined with integrated circuits on a single chip to provide built-in intelligence and signal processing.**



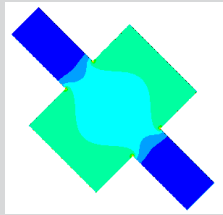
Silicon Ring Gyroscope – Harmonic response including thermoelastic damping solved with direct coupled-field elements.



Piezoelectric Fan

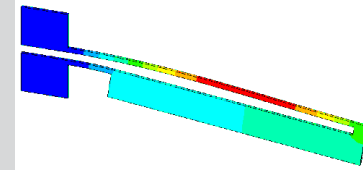


ANSYS Piezoelectric and MEMS Capabilities



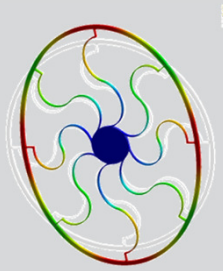
- **Piezoelectric**

- transducers, resonators, sensors and actuators, vibration control, accelerometers



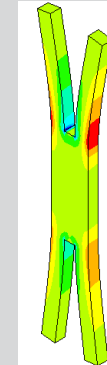
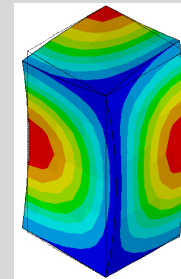
- **Piezoresistive**

- pressure sensors, strain gauges, accelerometers



- **Thermal-electric**

- wires, busbars, Peltier coolers, thermogenerators

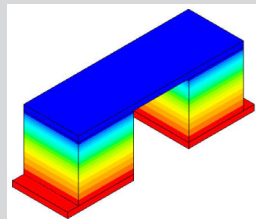


- **Thermoelastic damping**

- MEMS resonators

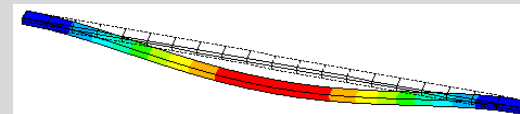
- **Electrostatic-structural**

- actuators

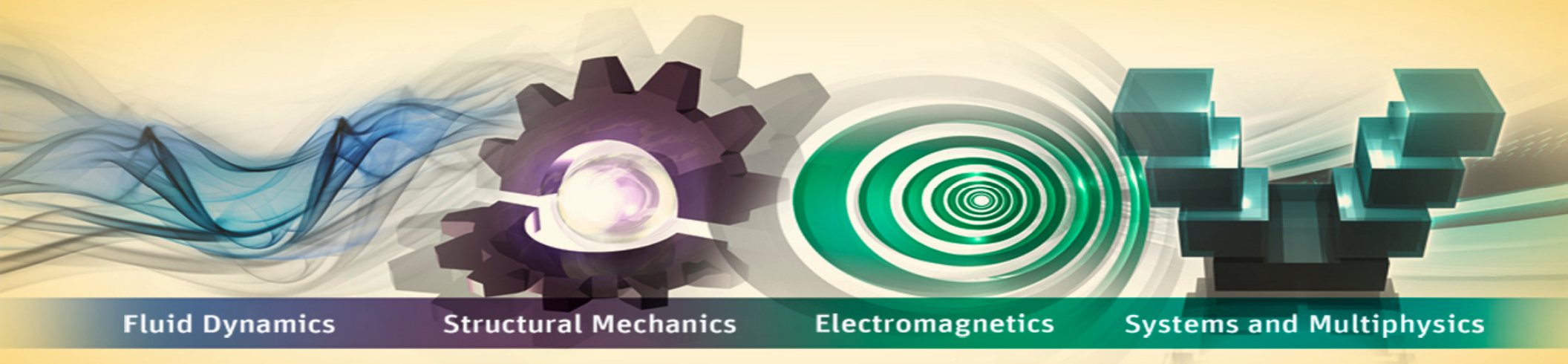


- **Coriolis effect**

- quartz angular velocity sensors

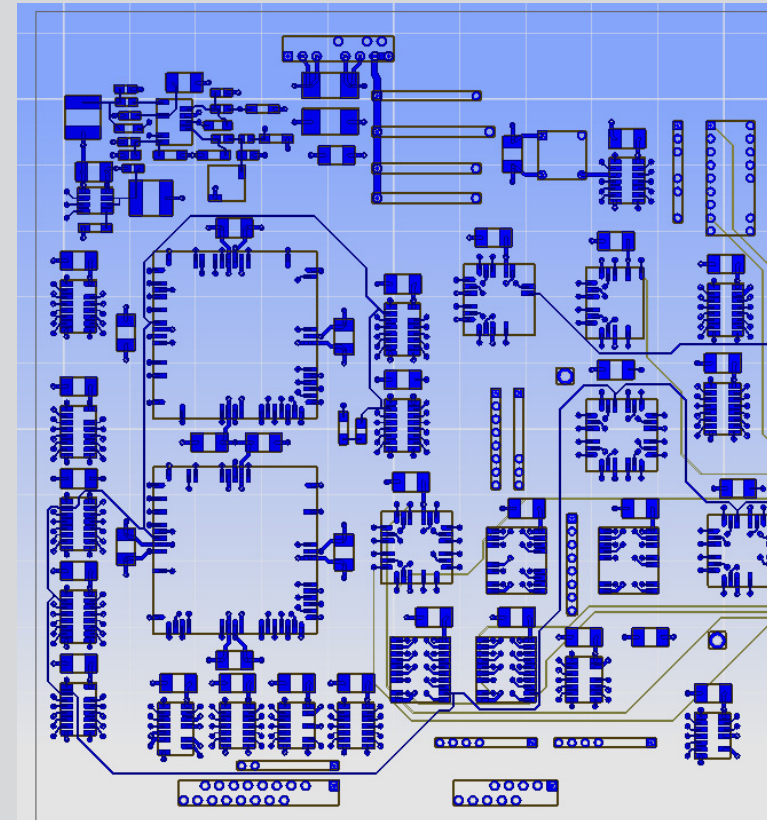


Workflow



Geometry import

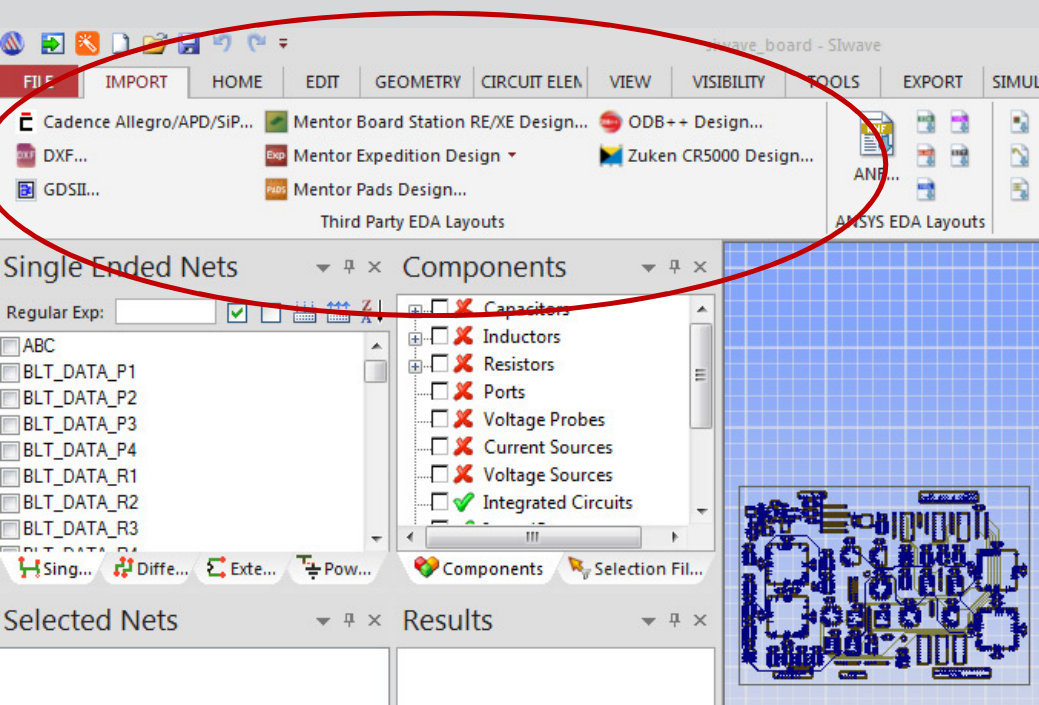
- MEMS devices are typically designed as 2D layout.
- To run a simulation, this 2D layout usually need to be converted into a 3D solid model.
- Current ANSYS Options
 - Alinks
 - Spaceclaim



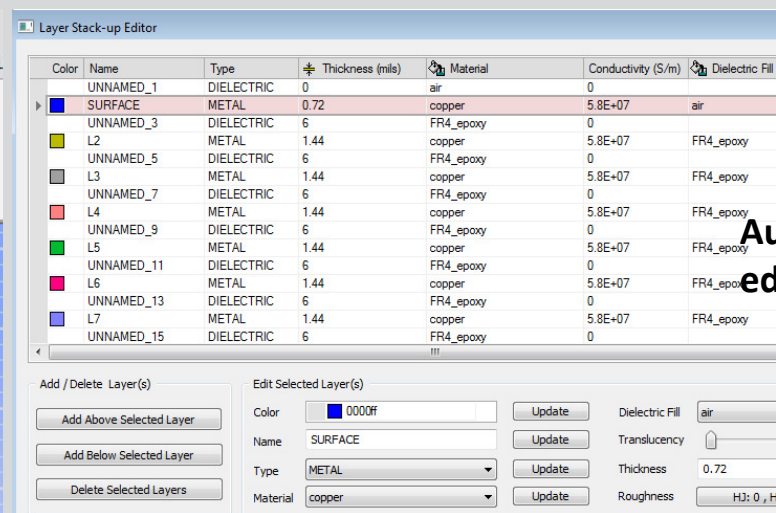
2D ECAD Layout



Alinks – Formerly called Ansoft Links



Alinks import options



Automatic stack-up editor

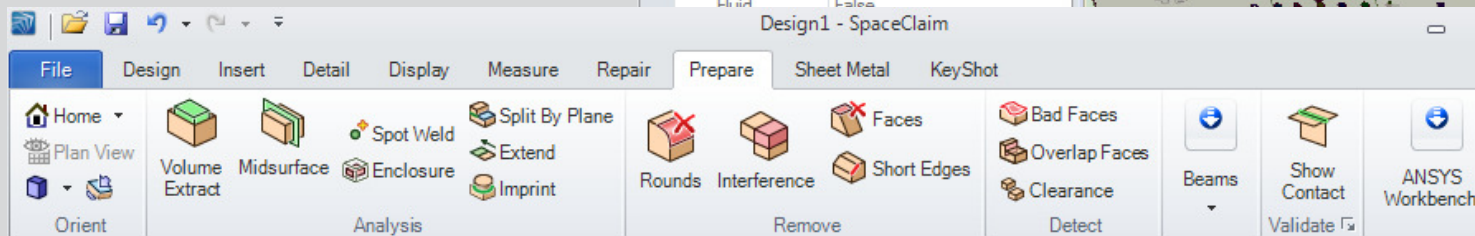
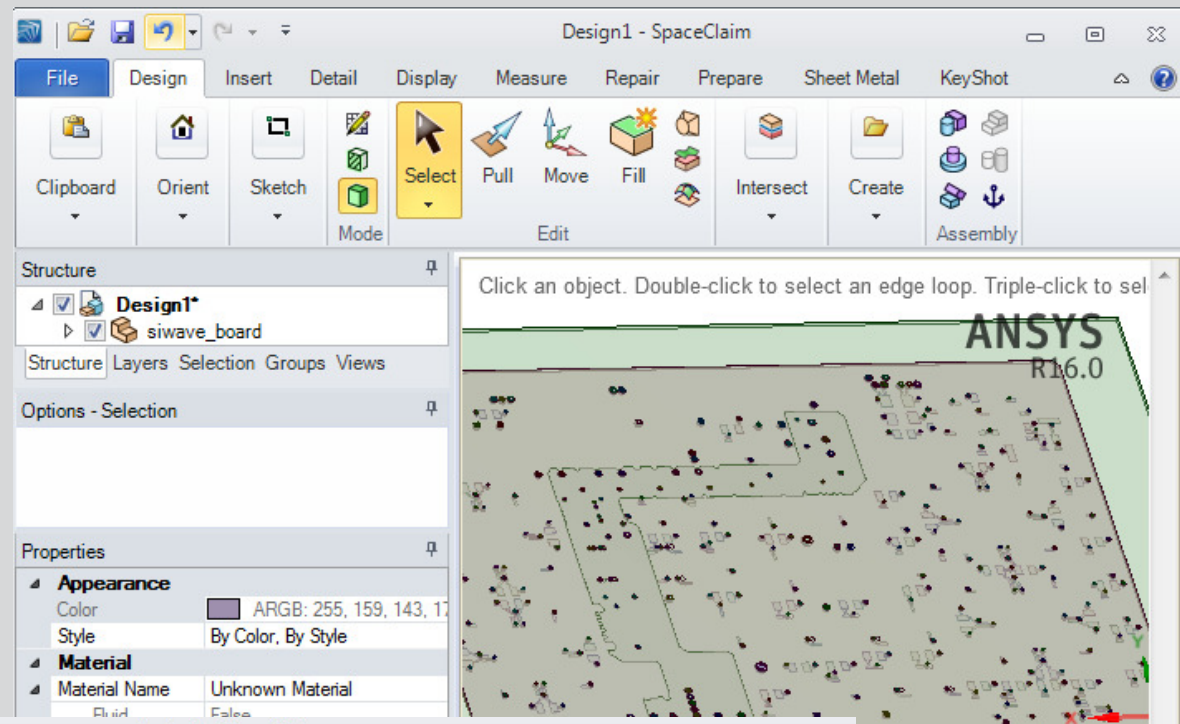
3D geometry created





ANSYS SpaceClaim

- **ANSYS SpaceClaim is a CAD preparation tool**
 - Intuitive
 - Easy to use
 - Powerful
- Support layout formats such as
 - DXF and DWG
 - Idf, idb and emn formats
- Supports many powerful simulation preparation capabilities



ANSYS Piezoelectric and MEMS Extension

Piezo and MEMS
Version: 2.0

Target Application: **Workbench Mechanical**
Expose piezo-electric and MEMS solver capabilities in Workbench

Download

- Download from the customer portal under Downloads>Application Library
- Free!

Piezoelectric And MEMS Body ▾

- Piezoelectric Body
- Thermal-Piezoelectric Body
- Piezoresistive Body
- Electroelastic Body
- Structural-Thermal Body
- Structural-Thermoelectric Body

Electric Charge
 Surface Charge Density
 Volume Charge Density
 Voltage
 Enforced Motion Voltage (Beta)
 Voltage Coupling

Temperature
 Convection
 Heat Generation
 Heat Flow
 Heat Flux
 Temperature Coupling

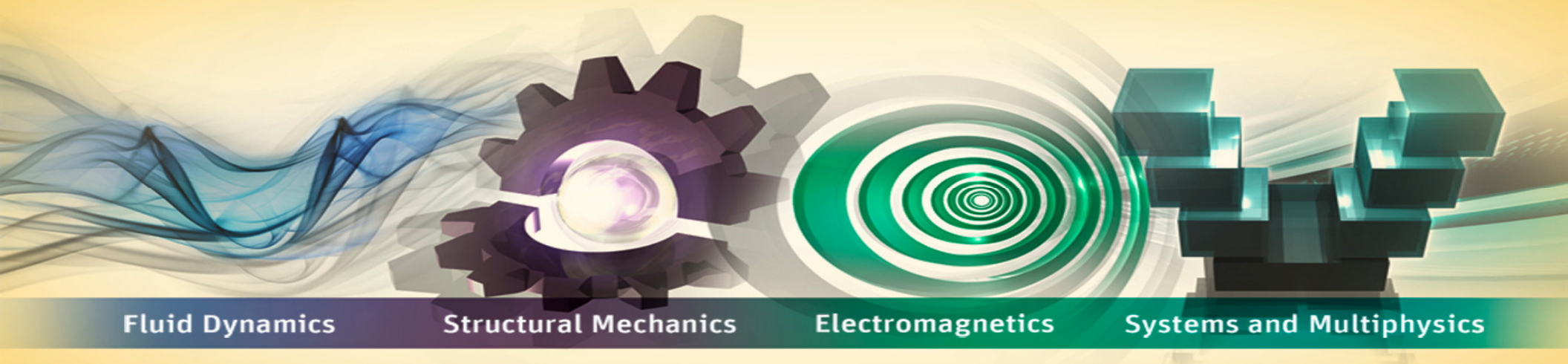
Squeeze Film Fluid
 Viscous Fluid Link
 Slide Film Fluid
 Pressure
 Pressure Coupling
 Velocity

**Import and export
Piezoelectric
material properties**

Frictionless Support 1
Frictionless Support 2
Fixed Support 2
Frictionless Support 3
Piezoelectric
Voltage v1
Voltage v2
Voltage g1
Voltage Coupling
Voltage g2
Solution (1)
Total Error
Comm1
Comm2
Duplicate
Copy
Cut

Insert
Show All Bodies
Suppress
Export
Import

Example Pressure Sensor



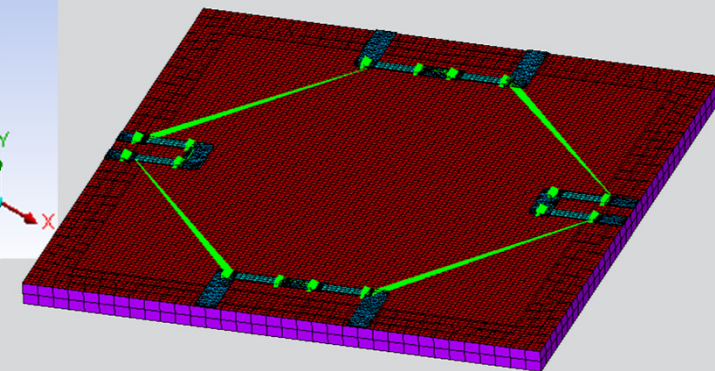
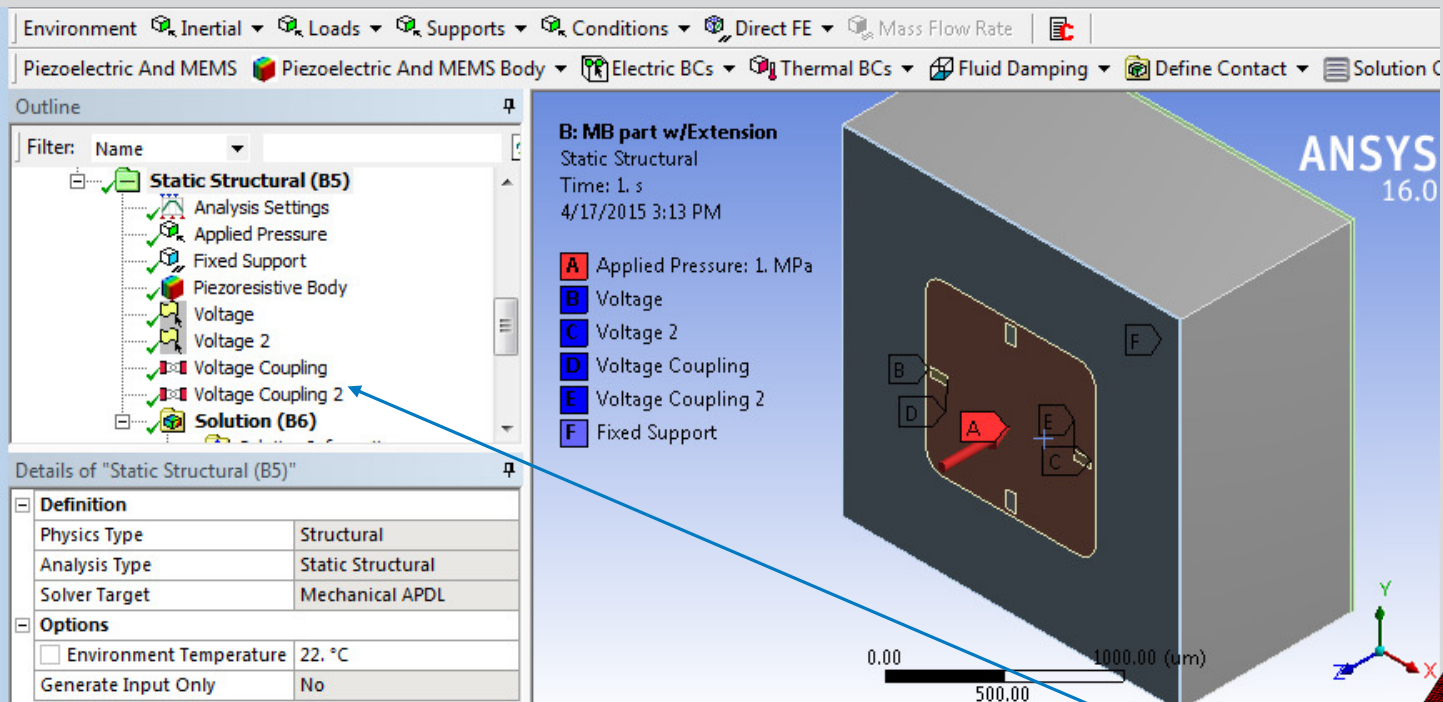
Fluid Dynamics

Structural Mechanics

Electromagnetics

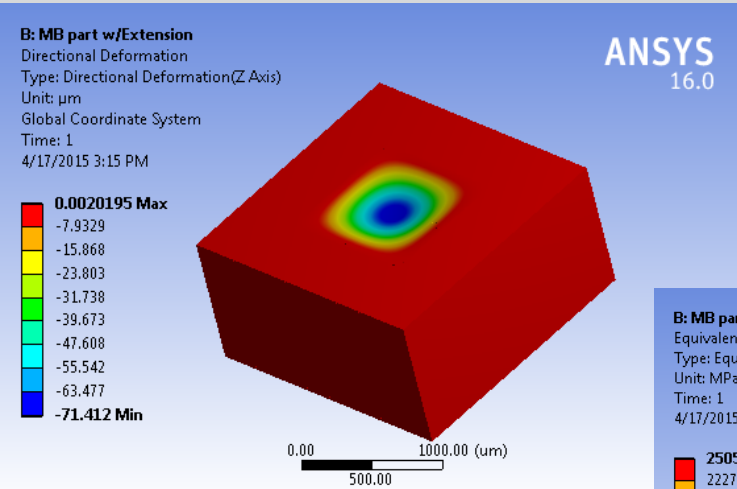
Systems and Multiphysics

Piezoresistive Pressure Sensor Setup

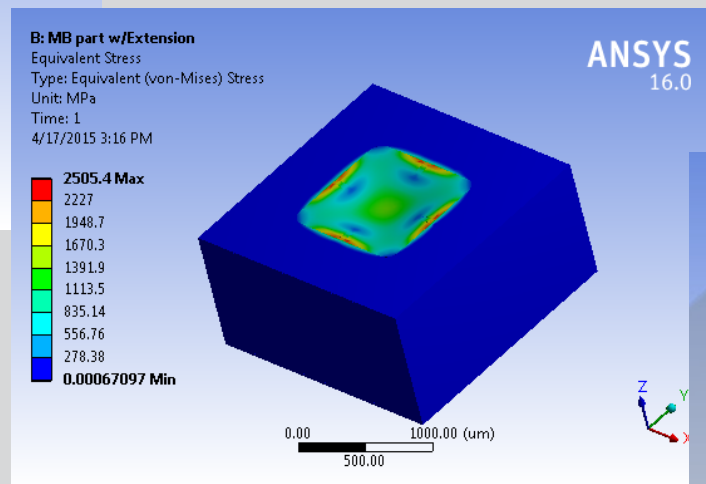


Voltage Coupling to create Wheatstone Bridge Circuit

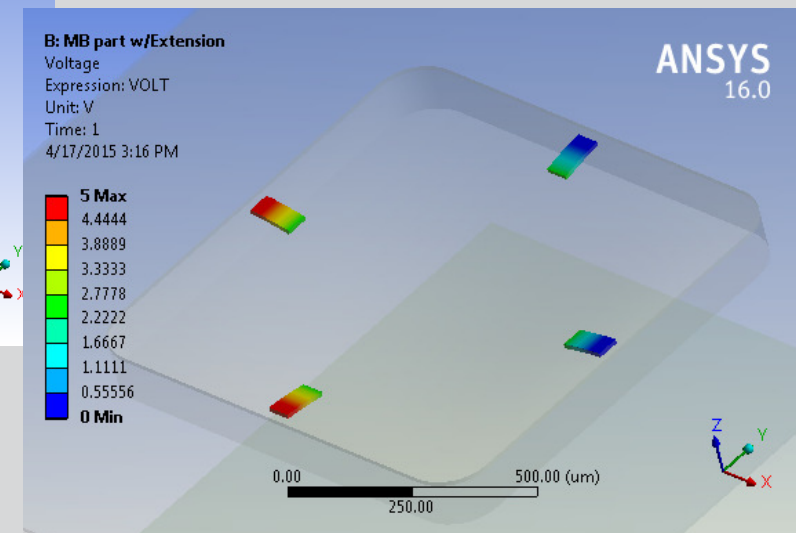
Deformation



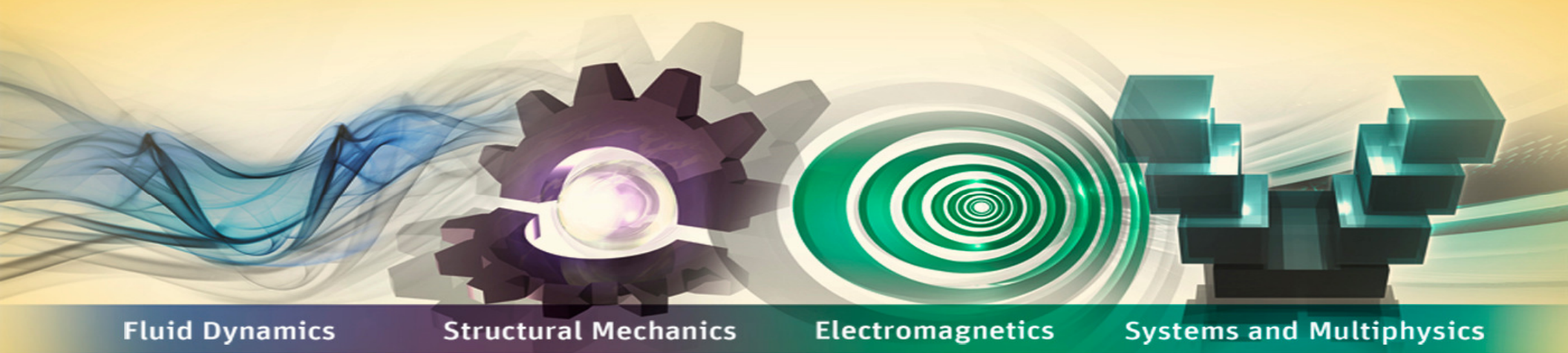
Stress



Voltage



Example Surface Acoustic Wave Resonator



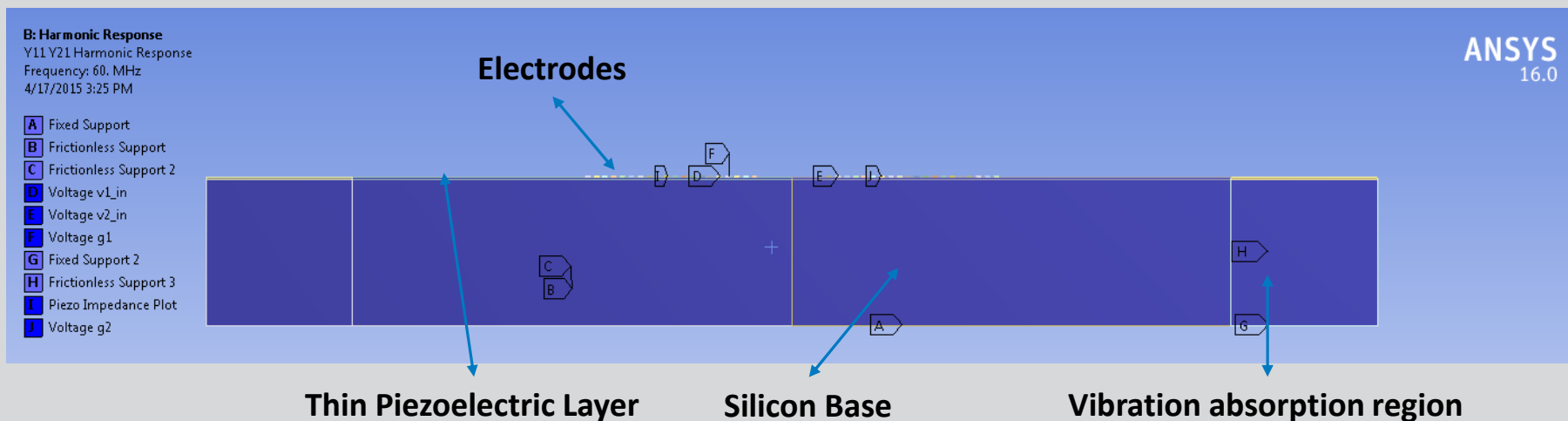
Fluid Dynamics

Structural Mechanics

Electromagnetics

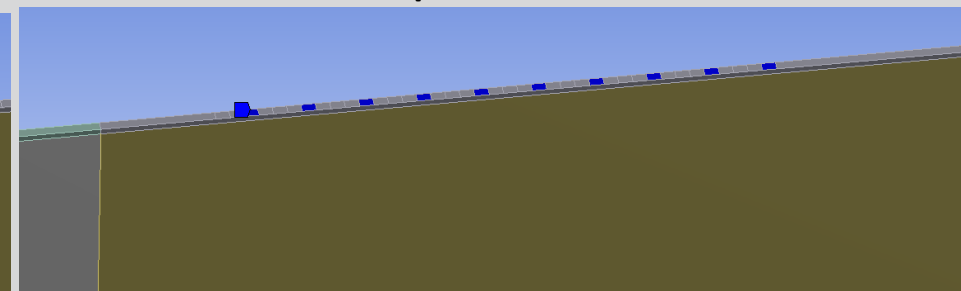
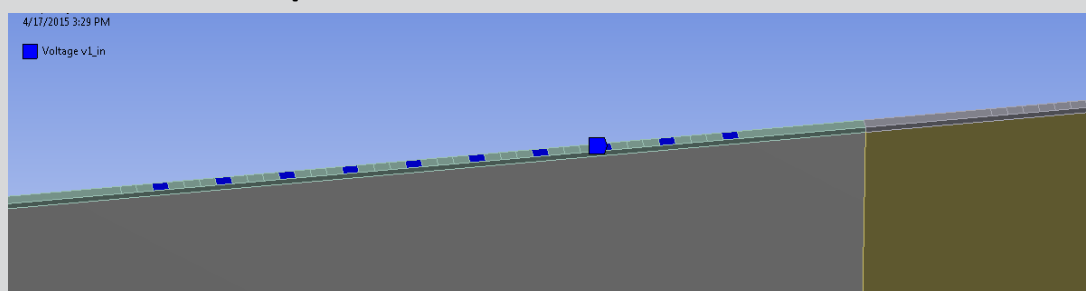
Systems and Multiphysics

Surface Acoustic Wave Resonator



Input Electrodes

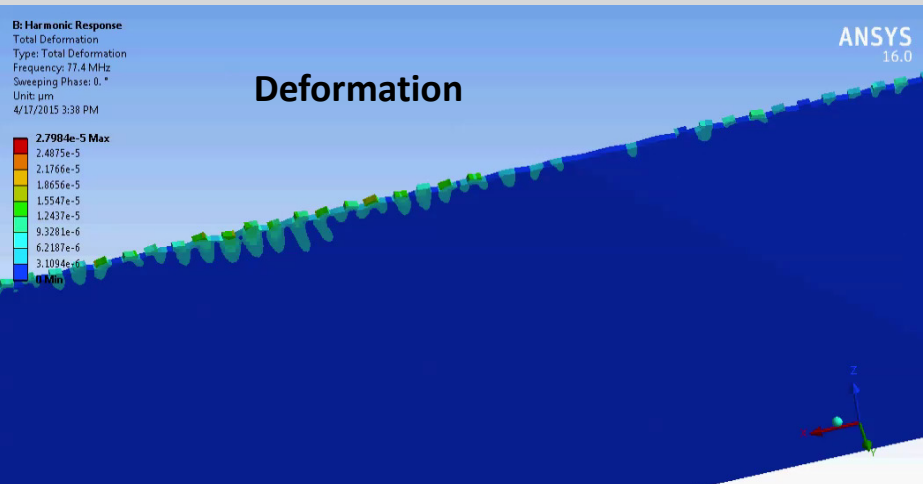
Output electrodes



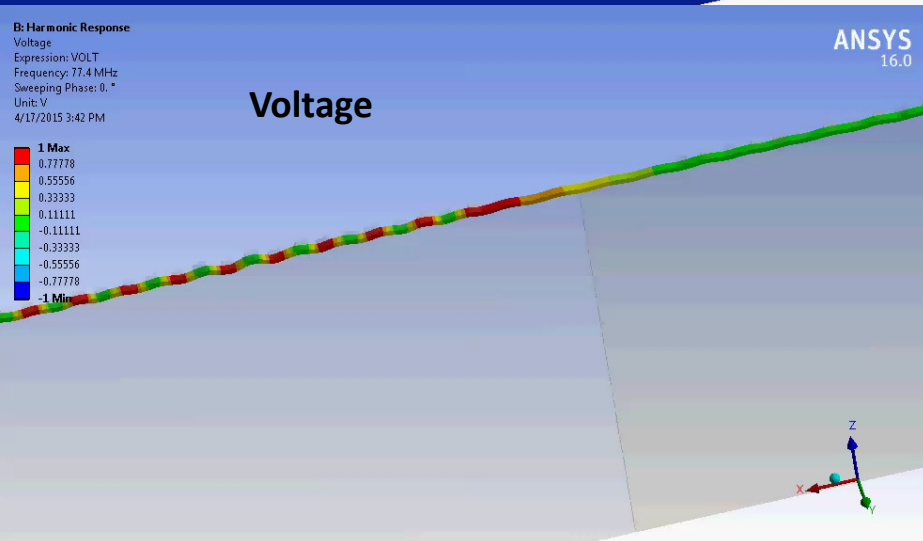


Results

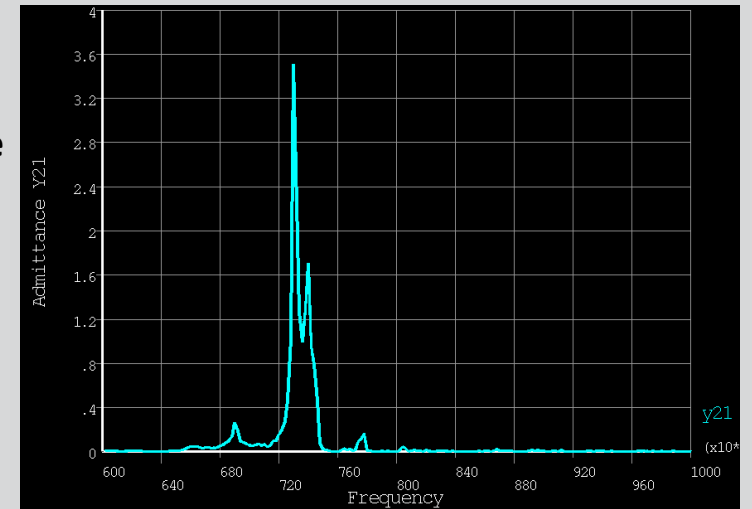
Deformation



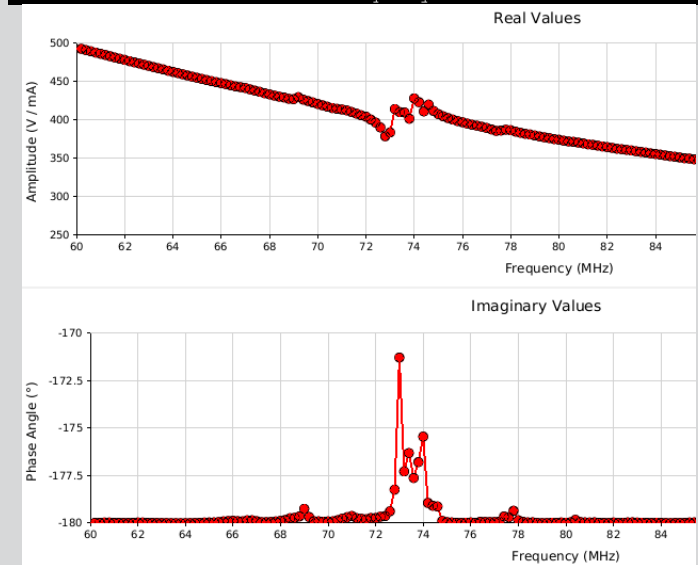
Voltage



Admittance



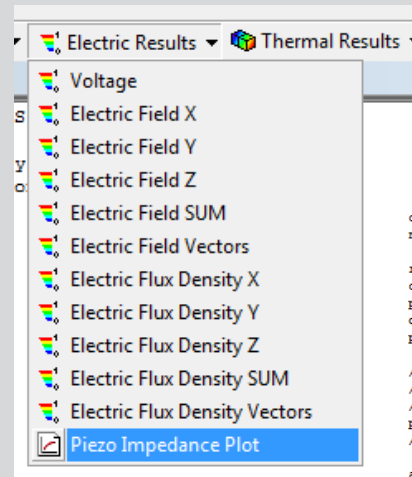
Impedance



- **New in ANSYS R16 Perfectly Matched Layers for Structural Element.**
 - Currently limited to isotropic elements
 - R17 - expected to be applicable to Piezoelectric elements as well
- Piezo Impedance Plot post processing available for 1 port system.
- Multiport impedance/admittance plots can be generated using APDL commands.

5.1.6. Perfectly Matched Layers (PML) for Structural Elements

[Perfectly matched layers \(PML\)](#) are artificial anisotropic materials that absorb all incoming elastic waves without any reflections to make the infinite elastic wave propagating domain into the finite numerical simulation domain for a harmonic analysis. PML are also used to truncate the infinite domain for a static solution. PML are defined by the [SOLID185](#), [SOLID186](#), and [SOLID187](#) elements with KEYOPT(15) = 1.



```

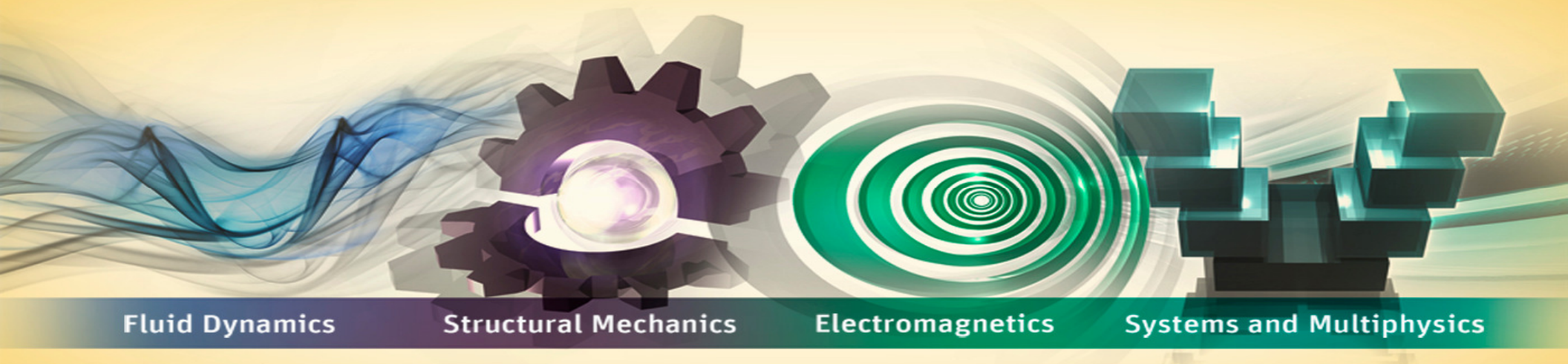
cmsel,s,v2_in      ! SELECT OUTPUT ELECTRODE NODES
n_pos=ndnext(0)    ! FIRST NODE IN SELECTED SET

rforc,6,n_pos,chrq ! VARIABLE 6: CHARGE Q2 AT CONSTRAINED MASTER NODE OF CP SET
cfact,0,2*acos(-1) ! FACTOR FOR "IA" VARIABLE IN SUBSEQUENT OPERATION: 0 + j*2*pi
prod,7,1,6,,current_pos ! VARIABLE 7: CURRENT i2 = jwQ2
quot,8,7,3,,y21      ! VARIABLE 8: Y21 = i2/V1
prvar,1,5,8

/sho,png           ! PLOT Y21{f}
/axl,x,Frequency
/axl,y,Admittance Y21
plva,8
/sho,close

allsel,all
    
```

Example Gyroscope



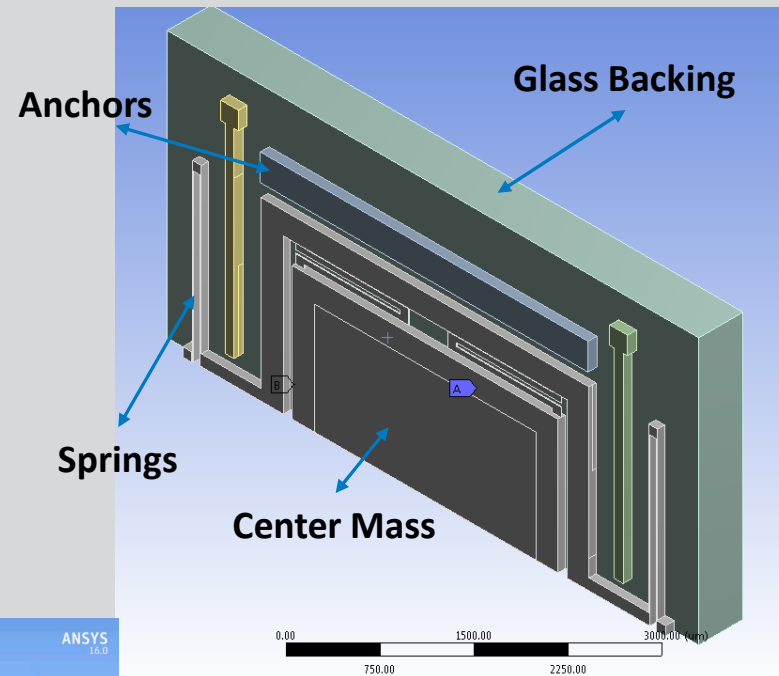
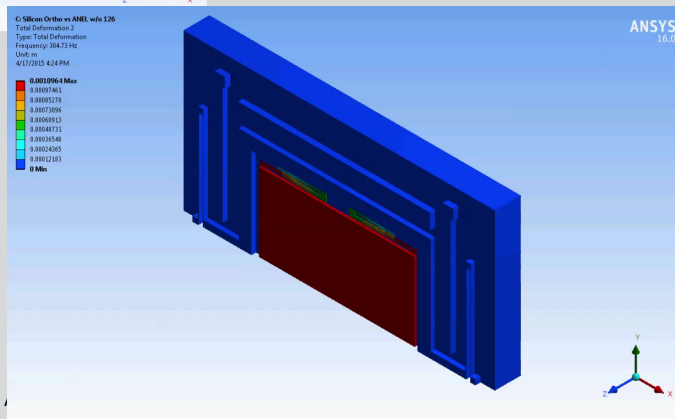
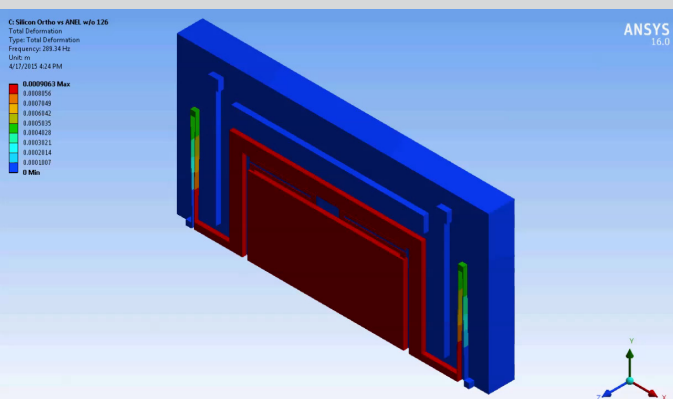
Fluid Dynamics

Structural Mechanics

Electromagnetics

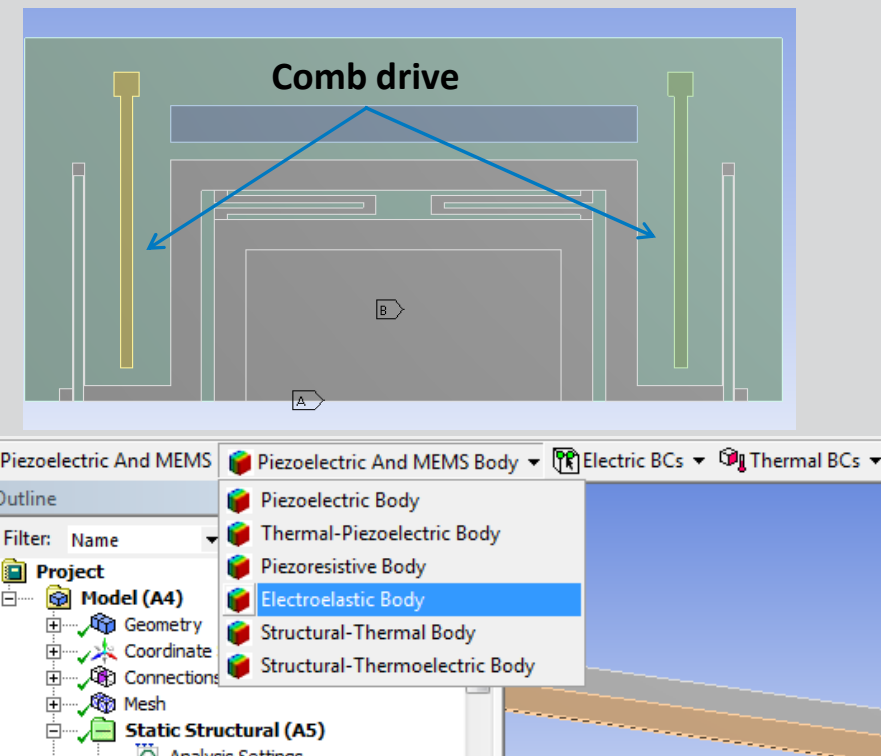
Systems and Multiphysics

- Start with basic modal analysis to calculate the resonant frequencies

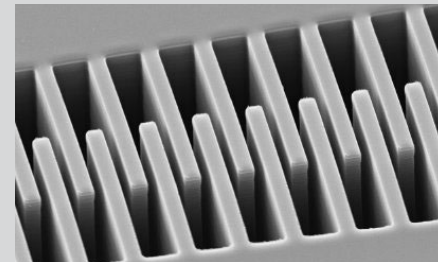


Mode	<input checked="" type="checkbox"/> Frequency [Hz]
1.	289.34
2.	304.73
3.	328.71
4.	2832.
5.	4920.8
6.	6444.9

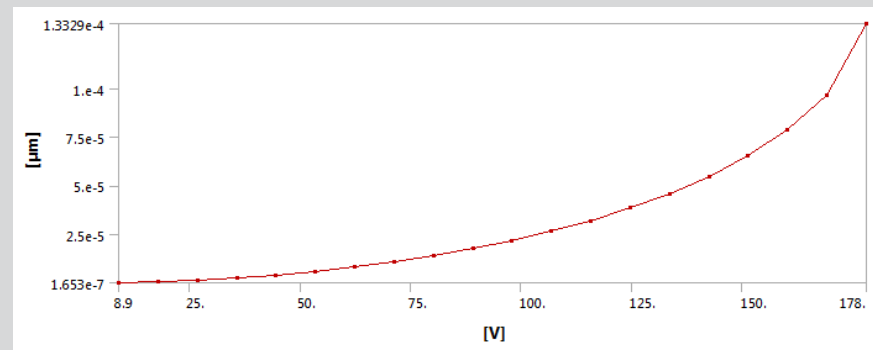
Gyroscopes are often driven by electrostatic forces



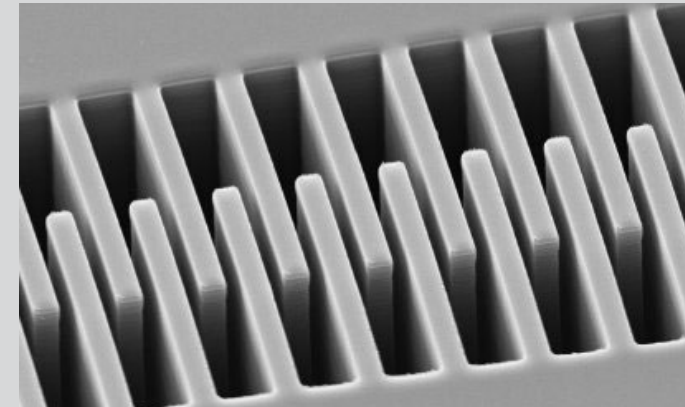
- Electrostatic voltage deflection behavior of the comb drive can be characterized using the Piezoelectric and MEMS extension in ANSYS Mechanical
- Electroelastic body will have other electrical and structural degrees of freedom and is used here to model the air gap.



Comb Drive



- Comb drives are geometrically complex and repetitive.
- Once characterized, they can be represented in ANSYS as electromechanical transducer elements
- These elements can be generated using a command script.

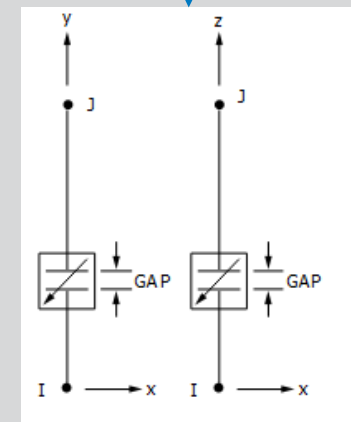
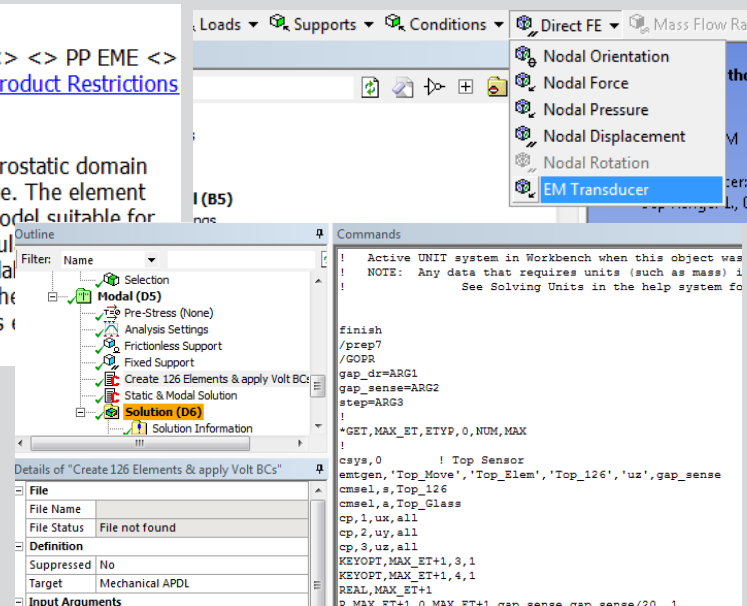


Electromechanical Transducer

MP <> <> <> <> <> <> PP EME <>
[Product Restrictions](#)

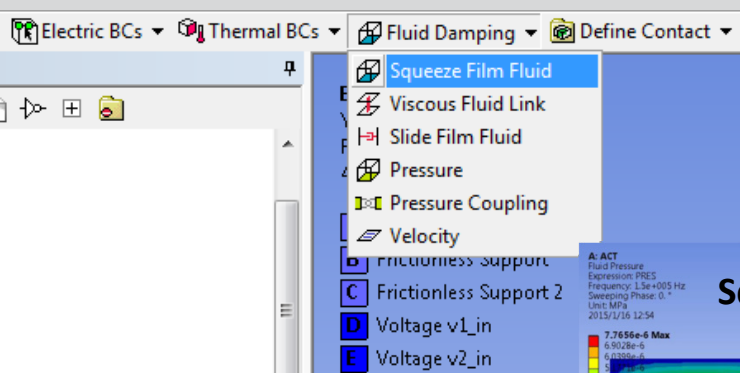
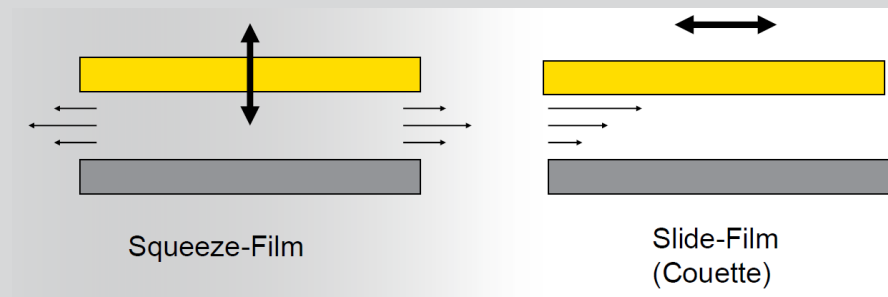
TRANS126 Element Description

TRANS126 represents a transducer element that converts energy from an electrostatic domain into a structural domain (and vice versa), while also allowing for energy storage. The element fully couples the electromechanical domains and represents a reduced-order model suitable for use in structural finite element analysis as well as electromechanical circuit simulation. The element has up to two degrees of freedom at each node: translation in the nodal direction and electric potential (VOLT). The element is suitable for simulating the electromechanical response of micro-electromechanical devices (MEMS) such as comb drives, capacitive transducers, and RF switches for example.



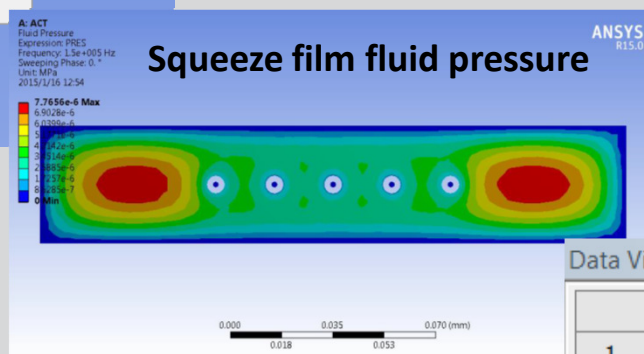
Damping

- The motion of the large center mass results in significant fluid damping.
- Fluid damping models are available in the Piezoelectric and MEMS extension



Viscous Link Element – Fluid138

- Models the viscous fluid flow behavior through short channels (holes) moving perpendicular to fixed surfaces.

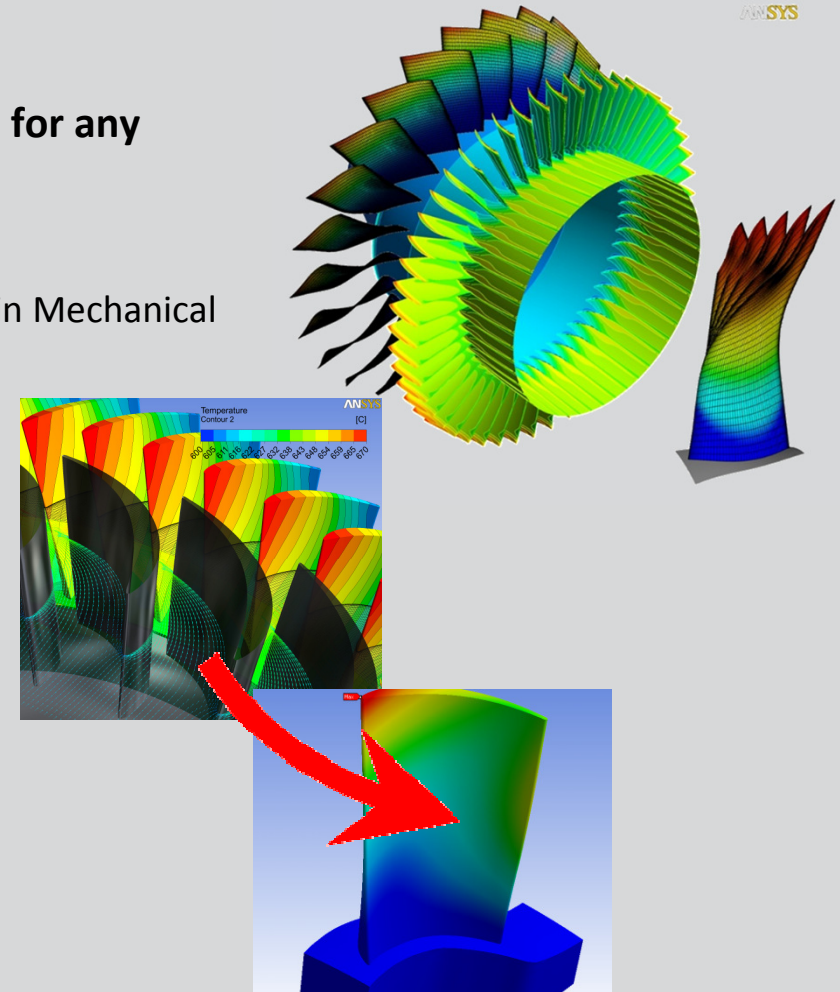
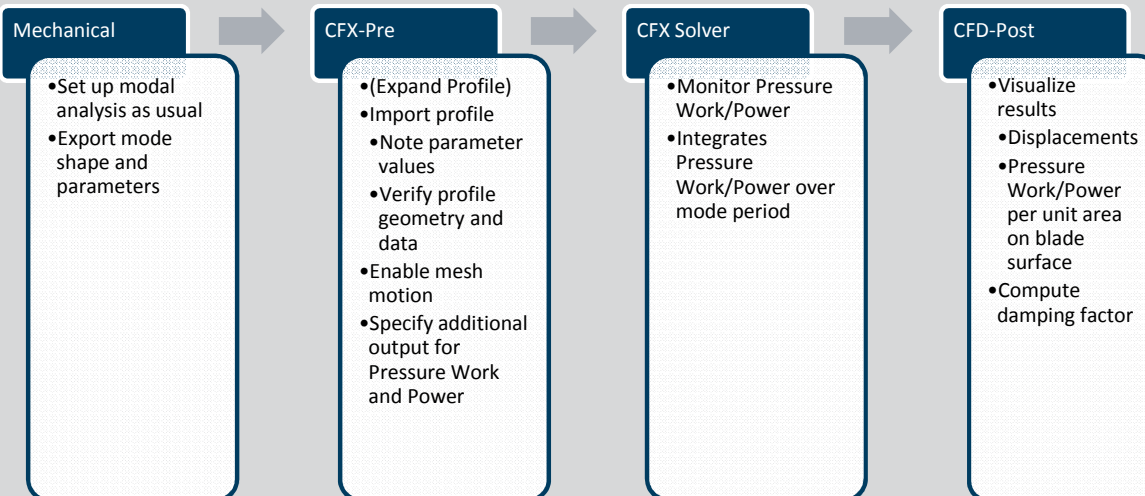


Extracted equivalent stiffness and damping

Data View			
	Frequency [Hz]	Equivalent Stiffness [N mm ⁻¹]	Equivalent Stiffness [N mm ⁻¹ s]
1	50000.0	6.11604e-05	1.33663e-08
2	100000.0	0.000244452	1.33571e-08
3	150000.0	0.00054931	1.33419e-08

More Damping

- Fluid damping can also be modeled using ANSYS CFD tools.
- Developed for turbo machinery applications, but can be used for any geometry.
- Also support forced response
 - Export complex pressure from CFD simulation for load application in Mechanical Harmonic simulations





Thank You!

- We at ANSYS are working hard to make Piezoelectric and MEMS simulations more accurate and easier to use.
- If you have questions or suggestions please contact me at mingyao.ding@ansys.com